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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 207.010-US)In the Application of: **LUTZ ET AL.**

) Group
) Art Unit: 2814
)
) Before
) Examiner: Le, Dung Anh
)
)

Serial No: **10/698,258**Filed: **OCTOBER 31, 2003**Title: **ANTI-STICKTION TECHNIQUE FOR THIN FILM
AND WAFER-BONDED ENCAPSULATED
MICROELECTROMECHANICAL SYSTEMS**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Date

Michiko Sato

(name of person signing certificate)



Signature

AMENDMENT AND REPLY OF DECEMBER 20, 2004

Dear Sir:

Kindly amend the application as follows: